International **T©R** Rectifier

REPETITIVE AVALANCHE AND dv/dt RATED HEXFET[®] TRANSISTOR

IRHN9230 P-CHANNEL RAD HARD

-200 Volt, 0.8Ω, RAD HARD HEXFET

International Rectifier's P-Channel RAD HARD technology HEXFETs demonstrate excellent threshold voltage stability and breakdown voltage stability at total radiation doses as high as 10⁵ Rads (Si). Under identical pre- and post-radiation test conditions, International Rectifier's P-Channel RAD HARD HEXFETs retain identical electrical specifications up to 1 x 10⁵ Rads (Si) total dose. No compensation in gate drive circuitry is required. In addition these devices are also capable of surviving transient ionization pulses as high as 1 x 10¹² Rads (Si)/Sec, and return to normal operation within a few microseconds. Single Event Effect (SEE) testing of International Rectifier P-Channel RAD HARD HEXFETs has demonstrated virtual immunity to SEE failure. Since the P-Channel RAD HARD process utilizes International Rectifier's patented HEXFET technology, the user can expect the highest quality and reliability in the industry.

P-Channel RAD HARD HEXFET transistors also feature all of the well-established advantages of MOSFETs, such as voltage control, very fast switching, ease of paralleling and temperature stability of the electrical parameters.

They are well-suited for applications such as switching power supplies, motor controls, inverters, choppers, audio amplifiers and high-energy pulse circuits in space and weapons environments.

Product Summary

Part Number	BV _{DSS}	R _{DS(on)}	ID
IRHN9230	-200V	0.8Ω	-6.5A

Features:

■ Radiation Hardened up to 1 x 10⁵ Rads (Si)

- Single Event Burnout (SEB) Hardened
- Single Event Gate Rupture (SEGR) Hardened
- Gamma Dot (Flash X-Ray) Hardened
- Neutron Tolerant
- Identical Pre- and Post-Electrical Test Conditions
- Repetitive Avalanche Rating
- Dynamic dv/dt Rating
- Simple Drive Requirements
- Ease of Paralleling
- Hermetically Sealed
- Surface Mount
- Light-weight

Absolute Maximum Ratings

Pre-Radiation

	Parameter	IRHN9230	Units
$I_D @ V_{GS} = -12V, T_C = 25^{\circ}C$	Continuous Drain Current	-6.5	
$I_D @ V_{GS} = -12V, T_C = 100^{\circ}C$	Continuous Drain Current	-4.0	Α
IDM	Pulsed Drain Current $_{igl()}$	-26	-
P _D @ T _C = 25°C	Max. Power Dissipation	75	W
	Linear Derating Factor	0.6	W/K _S
VGS	Gate-to-Source Voltage	±20	V
EAS	Single Pulse Avalanche Energy ₂	150	mJ
IAR	Avalanche Current	-6.5	А
EAR	Repetitive Avalanche Energy ①	7.5	mJ
dv/dt	Peak Diode Recovery dv/dt 3	-5.0	V/ns
Тј	Operating Junction	-55 to 150	
TSTG	Storage Temperature Range		°C
	Package Mounting	300 (for 5 seconds)	
	Surface Temperature		
	Weight	2.6 (typical)	g

	Parameter		Тур.	Max.	Units	Test Conditions
BVDSS	Drain-to-Source Breakdown Voltage	-200	—	—	V	VGS = 0V, ID = -1.0 mA
ΔBV _{DSS} /ΔTJ	Temperature Coefficient of Breakdown Voltage	—	-0.22	_	V/°C	Reference to 25°C, ID = -1.0 mA
RDS(on)	Static Drain-to-Source	—	—	0.8		VGS = -12V, ID = -4.0A VGS = -12V, ID = -6.5A
	On-State Resistance	—	—	0.92	Ω	
VGS(th)	Gate Threshold Voltage	-2.0		-4.0	V	$V_{DS} = V_{GS}$, $I_{D} = -1.0 \text{ mA}$
gfs	Forward Transconductance	2.5	—	—	S (び)	VDS > -15V, IDS = -4.0 A @
IDSS	Zero Gate Voltage Drain Current	—	—	-25		VDS = 0.8 x Max. Rating,VGS = 0V
		—	—	-250	μA	VDS = 0.8 x Max. Rating
						VGS = 0V, TJ = 125°C
IGSS	Gate-to-Source Leakage Forward			-100	nA	VGS = -20V
IGSS	Gate-to-Source Leakage Reverse	—	—	100		VGS = 20V
Qg	Total Gate Charge			45		VGS = -12V, ID = -6.5A
Qgs	Gate-to-Source Charge	—	—	10	nC	VDS = Max. Rating x 0.5
Qgd	Gate-to-Drain ("Miller") Charge	—	—	25		
td(on)	Turn-On Delay Time	—	—	50		$VDD = 100V$, $ID = -6.5A$, $RG = 7.5\Omega$
tr	Rise Time	—	—	90	ns	
^t d(off)	Turn-Off Delay Time	—	—	90	115	
tf	Fall Time	—	_	90		
LD	Internal Drain Inductance	_	TBD	_	nH	Measured from the drain lead, 6mm (0.25 in.) from package to center of die.
LS	Internal Source Inductance	—	TBD	_		Measured from the source lead, 6mm (0.25 in.) from package to source bonding pad.
C _{iss}	Input Capacitance	—	1100			$V_{GS} = 0V, V_{DS} = -25V$
C _{OSS}	Output Capacitance		310		pF	f = 1.0 MHz
C _{rss}	Reverse Transfer Capacitance		55	—		

Electrical Characteristics @ Tj = 25°C (Unless Otherwise Specified)

Source-Drain Diode Ratings and Characteristics

	Parameter	Min.	Тур.	Max.	Units	Test Conditions		
IS	Continuous Source Current	-	-	-6.5		Modified MOSFET symbol		
	(Body Diode)					showing the integral Reverse		
ISM	Pulse Source Current	_	—	-26	A	p-n junction rectifier.		
	(Body Diode)					- S		
VSD	Diode Forward Voltage	_	—	-5.0	V	Tj = 25°C, IS = -6.5A, VGS = 0V@		
t _{rr}	Reverse Recovery Time	_		400	ns	Tj = 25°C, IF = -6.5A, di/dt ≤ -100 A/μs		
QRR	Reverse Recovery Charge	_	—	3.0	μC	V _{DD} ≤ -50V ④		
ton	Forward Turn-On Time Intrinsic turn-on time is negligible. Turn-on speed is substantially controlled by LS + LD.							

Thermal Resistance

	Parameter	Min.	Тур.	Max.	Units	Test Conditions
RthJC	Junction-to-Case	—	—	1.67	K/W ©	
RthJ-PCB	Junction-to-PC board	—	TBD			Soldered to a copper-clad PC board

Radiation Performance of P-Channel Rad Hard HEXFETs

International Rectifier Radiation Hardened HEXFETs are tested to verify their hardness capability. The hardness assurance program at International Rectifier uses two radiation environments.

Every manufacturing lot is tested in a low dose rate (total dose) environment per MIL-STD-750, test method 1019. International Rectifier has imposed a standard gate voltage of -12 volts per note 6 and a V_{DSS} bias condition equal to 80% of the device rated voltage per note 7. Pre- and post-radiation limits of the devices irradiated to 1 x 10^5 Rads (Si) are identical and are presented in Table 1. The values in Table 1 will be met for either of the two low dose rate test circuits that are used.

Both pre- and post-radiation performance are tested and specified using the same drive circuitry and test conditions in order to provide a direct comparison. It should be noted that at a radiation level of 1×10^5 Rads (Si), no change in limits are specified in DC parameters.

High dose rate testing may be done on a special request basis, using a dose rate up to 1×10^{12} Rads (Si)/Sec.

International Rectifier radiation hardened P-Channel HEXFETs are considered to be neutron-tolerant, as stated in MIL-PRF-19500 Group D. International Rectifier P-Channel radiation hardened HEXFETs have been characterized in heavy ion Single Event Effects environment the results are shown in Table 3.

Table 1. Low Dose Rate 60

Table 1. Low Dose Rate $\otimes U$			9230		
Parameter		100K R	ads (Si)	Units	Test Conditions ⁽⁰⁾
		min. max.		Onito	
BV _{DSS}	Drain-to-Source Breakdown Voltage	-200 —		V	$V_{GS} = 0V, I_D = -1.0 \text{ mA}$
V _{GS(th)}	Gate Threshold Voltage	-2.0	-4.0	v	$V_{GS} = V_{DS}, I_{D} = -1.0 \text{ mA}$
IGSS	Gate-to-Source Leakage Forward	_	-100	nA	V _{GS} = -20V
I _{GSS}	Gate-to-Source Leakage Reverse	—	100	11/5	$V_{GS} = 20V$
IDSS	Zero Gate Voltage Drain Current	_	-25	μA	$V_{DS} = 0.8 \text{ x} \text{ Max Rating}, V_{GS} = 0 \text{V}$
R _{DS(on)1}	Static Drain-to-Source ④	_	0.8	Ω	V _{GS} = -12V, I _D = -4.0A
. ,	On-State Resistance One				
V _{SD}	Diode Forward Voltage		-5.0	V	$T_{C} = 25^{\circ}C, I_{S} = -6.5A, V_{GS} = 0V$

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Table 2. High Dose Rate ⑧

Parameter		10 ¹¹ Rads (Si)/sec 10 ¹² Rads (Si)/sec Min, Typ Max, Min, Typ, Max,					Units	Test Conditions	
					тур.				
VDSS Drain-to-Source Voltag	ge —	160 160 160		V	Applied drain-to-source voltage				
								during gamma-dot	
IPP	—	-60	—	_	-60	—	A	Peak radiation induced photo-current	
di/dt	—	-800	—	-	-160	_	A/µsec	Rate of rise of photo-current	
L ₁	27	—	—	0.5	—		μH	Circuit inductance required to limit di/dt	

Table 3. Single Event Effects (9)

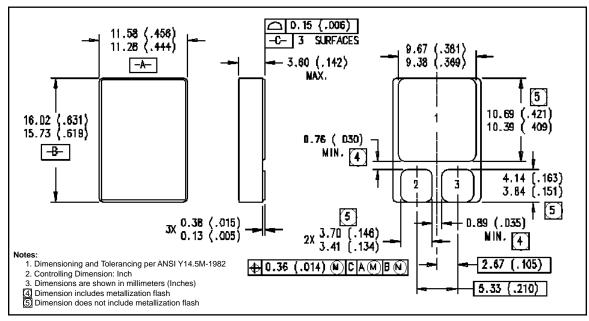
Deremeter		Linita	lan	LET (Si)	Fluence	Range	V _{DS} Bias	V _{GS} Bias
Parameter	Тур.	Units	Ion	(MeV/mg/cm ²)	(ions/cm ²)	(µm)	(V)	(V)
BVDSS	-200	V	Ni	28	1 x 10⁵	~41	-200	+5

IRHN9230 Device

Radiation Characteristics

- Repetitive Rating; Pulse width limited by maximum junction temperature. Refer to current HEXFET reliability report.
- ② @ VDD = -50V, Starting TJ = 25°C, EAS = [0.5 * L * (IL²) * [BVDSS/(BVDSS-VDD)] 25 ≤ RG ≤ 200Ω, IL = -6.5A, VGS = -12V
- 3 ISD \le -6.5A, di/dt \le -140 A/µs, VDD \le BVDSS, TJ \le 150°C
- ④ Pulse width \leq 300 µs; Duty Cycle \leq 2%
- 5 K/W = °C/W W/K = W/°C

- Total Dose Irradiation with V_{GS} Bias. -12 volt V_{GS} applied and V_{DS} = 0 during irradiation per MIL-STD-750, method 1019.
- ⑦ Total Dose Irradiation with VDS Bias. VDS = 0.8 rated BVDSS (pre-radiation) applied and VGS = 0 during irradiation per MIL-STD-750, method 1019.
- ⑧ This test is performed using a flash x-ray source operated in the e-beam mode (energy ~2.5 MeV), 30 nsec pulse.
- Process characterized by independent laboratory.
- Il All Pre-Radiation and Post-Radiation test conditions are <u>identical</u> to facilitate direct comparison for circuit applications.



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Data and specifications subject to change without notice. 6/96

Case Outline and Dimensions — SMD-1